Product Data

ELECTRONIC PRESSURE MEASUREMENT PRODUCTS

Model 1535 2-inch Stainless Steel Pressure Gauges for Semiconductor

DESCRIPTION

U.S. Gauge Model 1535 pressure gauges are designed and manufactured for ultrahigh-purity gas distribution equipment used in semiconductor manufacturing. These 2 inch, all stainless steel gauges are clean room produced, nitrogen purged, and double bagged in 3 mil nylon bag and 6 mil poly bag.

These instruments are compatible with many toxic and corrosive gases. Welded face seal connections provide a threadless pressure seal and virtually eliminate a major source of contamination. Also available in NPT connections.

The Model 1535 is available in pressure ranges from 0 to 30 inches Hg VAC, to 0 to 4000 psi. This precision gauge incorporates rugged case construction with rear pressure relief, and a seamless Bourdon tube with welded joints for heavy-duty service.

FEATURES

- Cleaning for UHP gas applications exceeding ANSI B40.1 specifications
- 10 Ra finish on face seal connections
- Helium leak tested to confirm leakage rates of less than 10-9 scc/sec.
- All stainless steel (Type 316L) internal surfaces for corrosion resistance
- Large, easy-to-read dial graduations
- Handles wide variety of exotic gases
- Available with welded face seal fittings, or NPT connection
- Assembled and packaged in Class 100 clean room
- Low mount or center back connections

SPECIFICATIONS

Size: 2 inch diameter

Case: Drawn stainless steel polished with pressure relief in

back of case

Ring and Window: One piece, threaded polycarbonate, or optional friction ring with polycarbonate or glass lens

Pointer: Aluminum, adjustable zero, black finish

Dial: Aluminum, white background with black markings

Bourdon Tube: Type 316L seamless stainless steel

Connection: Type 316L stainless steel, low mount or center back mount, male or female face seal fitting, or 1/4 inch male NPT – connectors are shipped with protective plastic caps

Surface Finish:

Face seal connections: 10 Ra 1/4 inch NPT connections: 32 Ra

Ranges: 30 inches Hg vacuum to 4000 psi, single or dual scale,

see ordering information

Overpressure: 110% of span maximum

Accuracy:

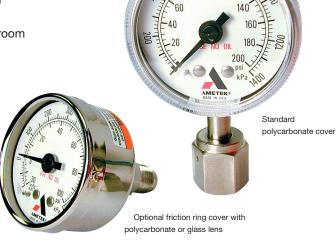
±1% of span (less than 3000 psi)

 $\pm 2\%$ of span for ranges 3000 psi and above

Scales: psi, bar, kg/cm², KPa, MPa (single or dual scale) inches Hg (for vacuum range, compound and vacuum gauges only)

Model 1535
UHP Semiconductor Gauge

shown with center back mount and low mount connections



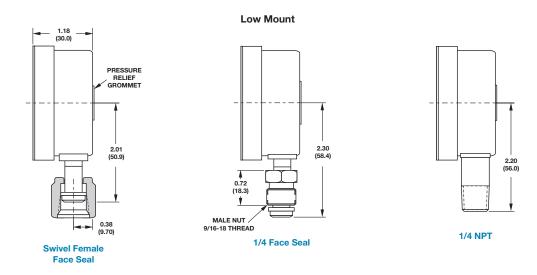


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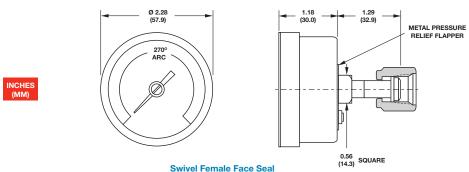


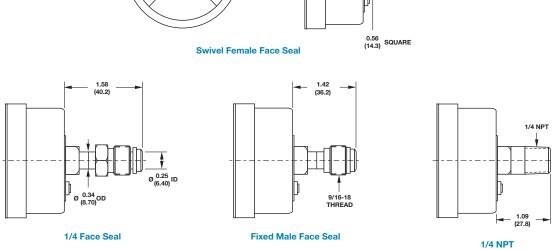
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Center Back Mount











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1535	2-inch stainless steel pressure gauges for semiconductor Pressure ranges			
•				
	0015 0030 0060 0100 0150 0160 0200 0300 0400 0600 1000	0 to 15 psi 0 to 30 psi 0 to 60 psi 0 to 100 psi 0 to 150 psi 0 to 160 psi 0 to 200 psi 0 to 300 psi 0 to 600 psi 0 to 1000 psi	2000 3000 4000 VAC V-0-15 V-0-30 V-0-100 V-0-150 V-0-160 V-0-200	0 to 2000 psi 0 to 3000 psi 0 to 4000 psi 0 to 4000 psi 0 to 30 inches Hg vacuum Compound (vac to 15 psi) Compound (vac to 30 psi) Compound (vac to 60 psi) Compound (vac to 100 psi) Compound (vac to 150 psi) Compound (vac to 150 psi) Compound (vac to 160 psi) Compound (vac to 160 psi) Compound (vac to 200 psi)
	1500 0 to 1500 psi		V-0-200 V-0-300	Compound (vac to 200 psi)
	PSI psi			
		IN.HG inches Hg (compound and vacuum) BAR bar KPA kPa PSI/BAR psi and bar PSI/KG psi and kg/cm² PSI/KPA psi and kPa KG/MPA kg/cm² and MPa		
		Process connection location		
		LM CBM	Low mount Center back m	nount
	Process connection type		n type	
			MVCR Male f	PT male fixed face seal swivel face seal fixed (center back mount only) e face seal swivel
			1 voit Tollia	
			• Options	



